Special Issue

Recent Advances in Micro/Nano-Fabrication

Message from the Guest Editors

In recent decades, micro/nano-fabrication technologies have been widely used to prepare non-destruction testing transducers, semiconductors, special functional surfaces, and medical interventional key components. These kinds of micro/nano-fabrication technologies include traditional cutting/dicing, laser machining, micro-3D printing, printed circuits, chemical machining, and optical machining. Micro/nano-fabrication technologies are the key factors with which to determine the functions of micro/nano-devices. We are pleased to invite you to submit your recent research papers and reviews on the micro/nano-fabrication, construction, performance, and functional integration of microdevices, as well as their multiple applications. This Special Issue aims to collect and present the recent advances in micro/nano-fabrication, as well as provide deep insights for future works. In this Special Issue. original research articles and reviews are welcome. Research areas may include (but not limited to) micro/nano-materials and processing as well as related engineering and technology. I/We look forward to receiving your contributions.

Guest Editors

Dr. Yao Liu

School of Mechanical Engineering, North University of China, Taiyuan 030051. China

Dr. Jinjie Zhou

School of Mechanical Engineering, North University of China, Taiyuan 030051. China

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Micromachines
Editorial Office
MDPI, Grosspeteranlage 5
4052 Basel, Switzerland
Tel: +41 61 683 77 34
micromachines@mdpi.com

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Editor-in-Chief

Prof. Dr. Ai-Qun Liu

Department of Electrical and Electronic Engineering, The Hong Kong Polytechnic University, Hong Kong, China

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